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 IN THE U.S. PATENT AND TRADEMARK OFFICE

June 1, 2005

Applicants : Takaomi NAKAYAMA et al
 For : TREATING SOLUTION FOR SURFACE TREATMENT OF
 METAL AND A METHOD FOR SURFACE TREATMENT

PCT International Application No.: PCT/JP2003/015868

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U.S. Application No.

(if known, see 37 CFR 1.5): Unknown

Atty. Docket No.: 4626.P0002US

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Commissioner for Patents

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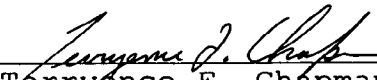
INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(1) and 1.98, enclosed herewith is a copy of the International Search Report, Form PTO-1449 and the Japanese reference cited thereon. The relevance of the references is explained on the enclosed search report. Accordingly, further comment at this point in time should not be necessary.

Respectfully submitted,

TFC/smd


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Encl: Copy of International Search Report
 Form PTO-1449 and one copy of Japanese reference

336.05/03

INFORMATION
 DISCLOSURE
 CITATION

App: Takaomi NAKAYAMA et al
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 Filed: Unknown
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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA			
	AB			
	AC			
	AD			
	AE			
	AF			
	AG			
	AH			
	AI			
	AJ			
	AK			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
/LZ/	AL	JP 2003-253461	09-10-2003	Yasushi et al	X
	AM				
	AN				
	AO				
	AP				

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	
	AR	
EXAMINER SIGNATURE		DATE CONSIDERED
/Lois Zheng/		02/26/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.